INTERNATIONAL GEMOLOGICAL INSTITUTE

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LABORATORY GROWN DIAMOND REPORT

October 27, 2026

IGI Report Number	LG845642444
Description	LABORATORY GROWN DIAMOND
Shape and Cutting Style	EMERALD CUT
Measurements	9.66 X 6.79 X 4.66 MM

GRADING RESULTS

Carat Weight	3.07 CARATS
Color Grade	E
Clarity Grade	VVS 2

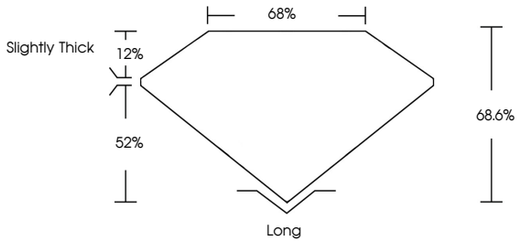
ADDITIONAL GRADING INFORMATION

Polish	EXCELLENT
Symmetry	EXCELLENT
Fluorescence	NONE
Inscription(s)	IGI LG845642444

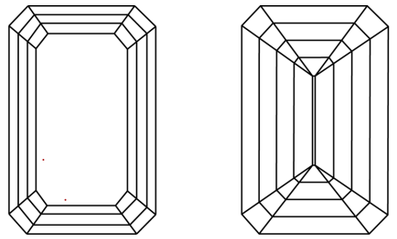
Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.
Type IIa

LG845642444
Report verification at igi.org

PROPORTIONS



CLARITY CHARACTERISTICS



KEY TO SYMBOLS

Red symbols indicate internal characteristics.
Green symbols indicate external characteristics.

www.igi.org



Sample Image Used

COLOR

D	E	F	G	H	I	J	Faint	Very Light	Light

CLARITY

FL	IF	VVS 1 - 2	VS 1 - 2	SI 1 - 2	I 1 - 3
Flawless	Internally Flawless	Very Very Slightly Included	Very Slightly Included	Slightly Included	Included

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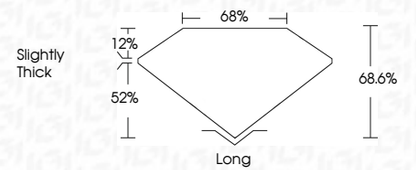
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IGI

October 27, 2026
IGI Report No LG845642444
EMERALD CUT
9.66 X 6.79 X 4.66 MM
3.07 CARATS
E
VVS 2
68.6%
65%
Slightly Thick
Long
EXCELLENT
EXCELLENT
NONE
IGI LG845642444
Comments:
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Type IIa